

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Hiroshi KUROSAWA) : Previous Examiner: D. Ben Esplin
Application No.: Divisional of Application No.) : Previous Group Art Unit: 2851
09/858,964, filed May 17, 2001 :
Filed: October 2, 2003 :
For: EXPOSURE APPARATUS, MAINTENANCE : October 2, 2003
METHOD THEREFOR, SEMICONDUCTOR)
DEVICE MANUFACTURING METHOD, AND:
SEMICONDUCTOR MANUFACTURING)
FACTORY :
)

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to examination on the merits, please amend the above-identified application as follows: